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MCDERMOTT, WILL & EMERY**F A C S I M I L E****TECHNOLOGY CENTER 2800****FROM:**

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Client/Matter/Tkpr: 43889-951-3328 Date: May 7, 2003 Time Sent: _____
Number of pages including this page: 3

TO:

Examiner Caridad M. Everhart
Name: Group Art Unit: 2825 Facsimile No. 703 872 9318
Company: U.S. Patent & Trademark Office Contact No. _____

RE: U.S. Patent Application Serial No. 09/610,640
For: APPARATUS AND METHOD FOR OPTICAL ...
SEMICONDUCTOR DEVICE
Attorney Docket No.: 43889-951

Applicants respectfully request that the attached page No. 30 be substituted for page 30 of the Amendment Under 37 CFR 1.111 filed with the USPTO on May 5, 2003. A copy of the date-stamped postcard is also attached.

Applicants have underlined the new matter which was presented in Claim 56 which underlining was inadvertently omitted in the Amendment filed on May 5, 2003.

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Serial No.: 09/610,640

calculating a change rate of a reflectance of the measurement light by dividing a difference between the respective reflectances of the measurement light in the presence and absence of said exciting light supplied to said semiconductor region by the reflectance of the measurement light in the absence of the exciting light;

wherein said exciting light is intermittently emitted at a frequency of 1 kHz or less in said step of supplying the exciting light.

56. (Amended) A method of manufacturing a semiconductor device [according to claim 49], said method comprising:

a first step of forming a substrate having a semiconductor region;

a second step of evaluating an optical property of said semiconductor region;

a third step of performing an etching process with respect to said semiconductor region;

and

a fourth step of controlling a condition for said etching process based on an optical property of said semiconductor region evaluated in said second step,

wherein dry etching [using] utilizing a plasma is performed in said third step.

62. (Twice Amended) A method of manufacturing a semiconductor device [according to claim 50], said method comprising:

a first step of forming a substrate having a semiconductor region;

a second step of evaluating an optical property of said semiconductor region;

a third step of performing an etching process with respect to said semiconductor region;

and

Applicant Koji ERIGUCHI, et al.Docket No. 43889-951Title: APPARATUS AND METHOD FOR OPTICAL EVALUATION, APPARATUS AND METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICE, AND SEMICONDUCTOR DEVICEDate Sent: 5/5/2003

Hand Carried



Fax



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Serial/Reg./Patent No.

09/610,640☐ Express Mail No.☐ Transmittal Letter

New Patent App



Utility



Design



Cont.



CIP



Div.



PCT



CPA



RCE



Prov

☐ Other:

_____ pages of Specification

_____ pages of Claims

_____ pages of Abstract

_____ pages of Formal/Informal Drawings



Small Entity



Large Entity



Declaration/Power of Attorney



Recordation of Assignment/Security Agreement



Information Disclosure Statement

Form PTO 1449

_____ copies of cited references



Preliminary Amendment



Response to Missing Parts Notice



Resp. to Notice to Correct App. Papers



Certified Copy of Priority Doc.



Claim for Convention Priority



Response/Amendment to Office Action of

4FEB03

Request for

_____ month Extension of Time



Letter submitting _____ pages of drawings



Req. for Approval of Drawing Amendments



Req. for Oral Hearing



Not. of Appeal



Appeal Brief



Reply Brief



Rule 312 Amendment/Letter



Req. for Acknowledgement of Cited Art



Issue Fee



Publication Fee



Req. for Certificate of Correction



Maintenance Fee for _____ years after grant



Fee Address Indication Form



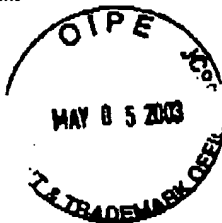
Terminal Disclaimer



Petition to Commissioner



Status Inquiry

Other Translations 8-296592; 8-350612; 9-015362; 9-189841

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THE PATENT AND TRADEMARK OFFICE DATE STAMPED HEREON IS ACKNOWLEDGEMENT THAT THE ITEMS, CHECKED ABOVE, WERE RECEIVED BY THE PTO ON THE DATE STAMPED.

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